

PATENT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Vishnu K. Agarwal and
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Attorney Docket No.: 500453.04

Filed : Concurrently Herewith

Title : POLISHING PADS AND PLANARIZING MACHINES FOR MECHANICAL OR
CHEMICAL-MECHANICAL PLANARIZATION OF MICROELECTRONIC-DEVICE
SUBSTRATE ASSEMBLIES, AND METHODS FOR MAKING AND USING SUCH
PADS AND MACHINES

INFORMATION DISCLOSURE STATEMENT

Box Patent Application
Commissioner of Patents
Washington, D.C. 20231

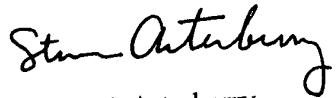
Sir:

In accordance with 37 C.F.R. §§ 1.56 and 1.97 through 1.98, applicants wish to make known to the Patent and Trademark Office the references set forth on the attached form PTO-1449. This application relies, under 35 U.S.C. § 120, on the earlier filing date of prior Application No. 09/621,021, filed July 21, 2000, which is a divisional of Application No. 09/201,576, filed November 30, 1998. The references listed on the attached Form PTO-1449 were submitted to and/or cited by the Patent and Trademark Office in these prior applications and, therefore, are not required to be provided in this application. If the Examiner wishes, copies will be provided upon request. Although the aforesaid references are made known to the Patent and Trademark Office in compliance with applicants' duty to disclose all information they are aware of which is believed relevant to the examination of the above-identified application, applicants believe that their invention is patentable.

Please acknowledge receipt of this Information Disclosure Statement and kindly
make the cited references of record in the above-identified application.

Respectfully submitted,

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Enclosure:
Form PTO-1449

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